



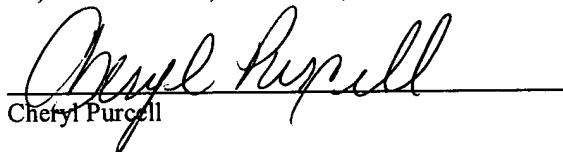
DOCKET NO: VSEA 44-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul S. Buccos
Serial No: 10/761,768
Confirmation No: 2891
Filed: January 21, 2004
For: ION IMPLANTER SYSTEM, METHOD AND PROGRAM
PRODUCT INCLUDING PARTICLE DETECTION
Examiner: Kiet Tuan Nguyen
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 26th day of November, 2004.



Cheryl Purcell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

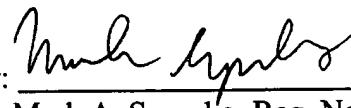
Sir:

Petition for Extension of Time

A one-month extension of time to November 29, 2004 is requested for response to the Examiner's Restriction Requirement of September 29, 2004.

The extension fee of \$110.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,
Paul S. Buccos, Applicant

By: 

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